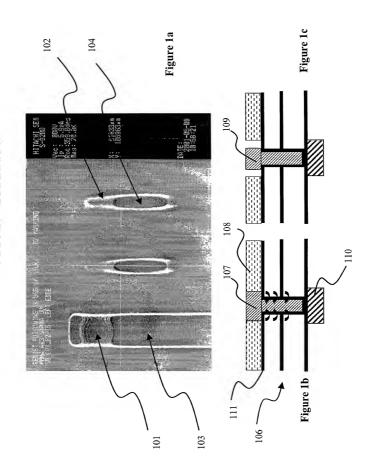
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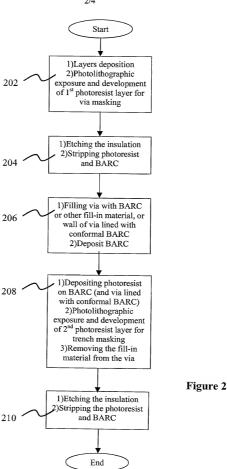
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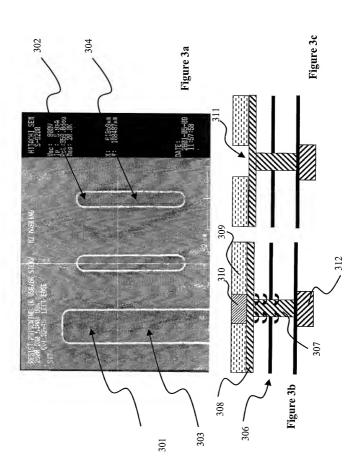




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Applicants: Cher Huan TAN et al.
Title: Method For Preventing Photoresist Poisoning In
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